PTO/SB/08a/b (08-03)
Approved for use through 07/31/2008. OMB 0851-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/B/PTO				Complete if Known		
Subs	Stitute for form 1445% B/P			Application Number	09/938,644-Conf. #1172	
IN	IFORMATIO	N DISC	LOSURE	Filing Date	August 27, 2001	
	TATEMENT			First Named Inventor	Neal Rueger	
Ŭ	,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,			Art Unit	1765	
	(Use as many sheets as necessary)			Examiner Name	T. Mackey Alanko	
Sheet	1 .	of	2	Attorney Docket Number	M4065.0466/P466	

			U.S. PA	TENT DOCUMENTS	
Eversions	Č:10	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant
	Cite No.1	Number-Kind Code ² (If known)	MM-DD-YYYY	Applicant of Cited Document	Figures Appear
des	Α	5,976,347	11/1999	Wakabayashi et al.	
	В	6,103,399	8/2000	Smela et al.	
	С	5,972,193	10/1999	Chou et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ -Number Hind Code ⁶ (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ¹ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language Translation is attached.

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
HIL	C1	MARC SCHAEPKENS et al.; "Asymmetric microtrenching during inductively coupled plasma oxide etching n the presence of a weak magnetic field", Applied Physics Letters, Vol. 72, Number 11, March 16, 1998. pp 1293 - 5	
	C2	K. DONOHOE; "Aspect Ratio-Plasma Effects" March 14, 2000.	<u> </u>
	C3	"Introduction to Microengineering, Mask Design", http://www.dbanks.demon.co.uk/ueng/maskdes.html_accessed July 3, 2001.	
	C4	"Introduction to Microengineering, LIGA", http://www.dbanks.demon.co.uk/ueng/liga.html accessed July 3, 2001.	
	C5	"Introduction to Microengineering, Excimer laser micromachining", http://www.dbanks.demon.co.uk/ueng/excimerum.html_accessed_July 3, 2001.	
	C6	"Introduction to Microengineering, Wafer bonding", http://www.dbanks.demon.co.uk/ueng/waferbond.html_accessed_July 3, 2001.	
	C7	"Introduction to Microengineering, Electrochemical etching of silicon", http://www.dbanks.demon.co.uk/ueng/electrochem.html_accessed_July 3, 2001.	
	C8	"Introduction to Microengineering, Surface micromachining", http://www.dbanks.demon.co.uk/ueng/surfum.html_accessed_July 3, 2001.	
	C9	"introduction to Microengineering, Basic Structures", http://www.dbanks.demon.co.uk/ueng/sistruct.html accessed July 3, 2001.	
	C10	"Introduction to Microengineering, Lift off", http://www.dbanks.demon.co.uk/ueng/liftoff.html accessed July 3, 2001.	
	C11	"Introduction to Microengineering, Dry Etching", http://www.dbanks.demon.co.uk/ueng/dryetch.html accessed July 3, 2001.	
	C12	"Introduction to Microengineering, Wet etching", http://www.dbanks.demon.co.uk/ueng/wetetch.html accessed July 3, 2001.	
1	C13	"introduction to Microengineering, Thin films", http://www.dbanks.demon.co.uk/ueng/Thin films.html accessed July 3, 2001.	

Anta K. Heinlo 4/9/0x

1734896 v1; 116NK011.DOC

MAR O 2 2004 S

PTO/SB/08a/b (08-03)
Approved for use through 07/31/2008. OMB 0851-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Complete if Known Substitute for form 1449A/B/PTO Application Number 09/938,644-Conf. #1172 August 27, 2001 INFORMATION DISCLOSURE Filing Date First Named Inventor Neal Rueger STATEMENT BY APPLICANT 1765 Art Unit (Use as many sheets as necessary) T. Mackey Alanko Examiner Name Attorney Docket Number M4065.0466/P466 2 of 2 Sheet

AUS	C14	"Introduction to Microengineering, Basic techniques", http://www.dbanks.demon.co.uk/ueng/sitech.html_accessed_July 3, 2001.	
	C15	"Integrated MicroElectroMechanical Systems", http://www.mdl.sandia.gov/micromachine/integrated.html accessed July 3, 2001.	
	C16	"Summit Technology", http://www.mdl.sandia.gov/micromachine/trilevel.html accessed July 3, 2001.	_
	C17	"MEMS Overview", http://www.mdl.sandia.gov/micromachine/overview.html accessed July 3, 2001.	
	C18	"Vision for MEMS", http://www.mdl.sandia.gov/micromachine/vision.html accessed July 3, 2001.	
1	C19	PHILIP BALL; "Honey, I shrunk the cogs", http://www.nature.com/nsu/010111/010111-3.html July 12, 2001.	

Examiner	1 1 011	Date 11/0/ 11	
LABITIME	dont a V 1 Stoules	11/14/2011	
Signature	TATUULLU K. LATUUUGA	Considered 14/7/04	
Signature	07 - 535 76 - 5	Contracted 177 1-1	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

org/pt/vol-54/iss-3/p9. html, accessed
7/12/01.

¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.